



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Akihiko HARADA et al.**

Group Art Unit: **2826**

Application Number: **09/717,143**

Examiner: **Ahmed N. Sefer**

Filed: **November 22, 2000**

Confirmation Number: **2927**

For: **INSULATED GATE TYPE SEMICONDUCTOR DEVICE AND
METHOD FOR FABRICATING SAME**

Attorney Docket Number: **001545**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCESSING REQUESTED

MAILSTOP: AF

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

Date: June 7, 2005

Sir:

In response to the Office Action dated February 7, 2005, **the response date of which
having been extended by one month to June 7, 2005**, Applicants submit the following remarks.

Remarks/Arguments begin on page 2 of this paper.